

## Responsibility for Damage to 3D X-ray Microscope and Accessories

### Recognition of Liability for Damage

- The Xradia Versa 510 contains extremely sensitive mechanical, optical, and electronic components.
- Do not touch anything within the enclosure except for the following components, or unless instructed by a Zeiss service personnel:
  - \*Sample stage while loading the sample holder assembly
  - \*X-ray source, when installing a source filter as instructed during training.
- A copy of this form signed by your supervisor must be submitted prior to use of the 3D X-ray Microscope.
- By submitting a request to use the 3D X-ray Microscope, you and your supervisor agree to absorb any cost that may be incurred as a result of your actions during any requested set-up and scanning time that has caused any mechanical, optical or electrical issues, or malfunctions of any of the equipment or software in the X-ray microscope laboratory.
- You agree to report immediately any issues to any of the super users and Prof. Laura Pyrak-Nolte ([ljpn@purdue.edu](mailto:ljpn@purdue.edu) room 164 PHYS, 765 494 3005).

### Recognition of Facility Acknowledgement

- By submitting a request to use the 3D X-ray Microscope, you and your supervisor agree to acknowledge the 3D XRM facility and personnel in your publications, posters, or oral presentations for either of the cases outlined below:

- If scanning and/or image analysis and segmentation was performed by any of the 3D XRM personnel please acknowledge as follows:

**Acknowledgment:** We acknowledge Chven Mitchell (or name of the personnel who assisted you) from the the 3D X-Ray Microscope Facility in the Department of Physics and Astronomy who assisted/acquired/analyzed the images of XXX for this paper on a Zeiss Xradia 510 Versa 3D X-ray Microscope that was supported by the Executive Vice President for Research and Partnerships, Major Multi-User Equipment Program 2017 at Purdue University.

- If the user performed all scanning and image analysis, please use the following acknowledgement:

**Acknowledgment:** We acknowledge the 3D X-Ray Microscope Facility in the Department of Physics and Astronomy for the images of XXX shown in this paper, which were acquired on

a Zeiss Xradia 510 Versa 3D X-ray Microscope that was supported by the Executive Vice President for Research and Partnerships, Major Multi-User Equipment Program 2017 at Purdue University.

### User Information

|                |       |                               |       |
|----------------|-------|-------------------------------|-------|
| Employee Name: | _____ | Date of<br>Overview Training: | _____ |
| Employee ID:   | _____ | Department:                   | _____ |
| Email:         | _____ | Telephone:                    | _____ |

### Professor/Supervisor Approval

|             |       |
|-------------|-------|
| Supervisor: | _____ |
| Email:      | _____ |
| Telephone:  | _____ |
| Signature:  | _____ |

### Confirmation of Receipt

|                |       |
|----------------|-------|
| Date Received: | _____ |
| Approval       | _____ |